

Op. 2872

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re of Applicant)
Shojiro KAWAKAMI et al.) Art Group:
Serial No.: 09/402,112)
Filing Date: February 18, 2000)
Title: THREE-DIMENSIONAL) Examiner:
PERIODIC STRUCTURE, ITS)
FABRICATION METHOD, AND)
METHOD OF FABRICATION FILM)



RESPONSE

Hon. Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

Responsive to the Office Action dated November 15, 2000,
having a due date of December 15, 2000, Applicant hereby submits
the following Amendment.

REMARKS

Claims 1 - 18 stand pending in the present application.

The Examiner requests an election of invention between one
of fourteen groups. Applicant, at this time, restricts this
application to Group I, claims 5 and 6, drawn to a three
dimensional periodic structure including silicon or related
methods of forming same.

Applicant is aware of 37 CFR 1.48(b) and no correction of
inventorship is necessary at this time.

#9
Election
J. McMillan
12/21/00

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TC 2000 MAIL ROOM